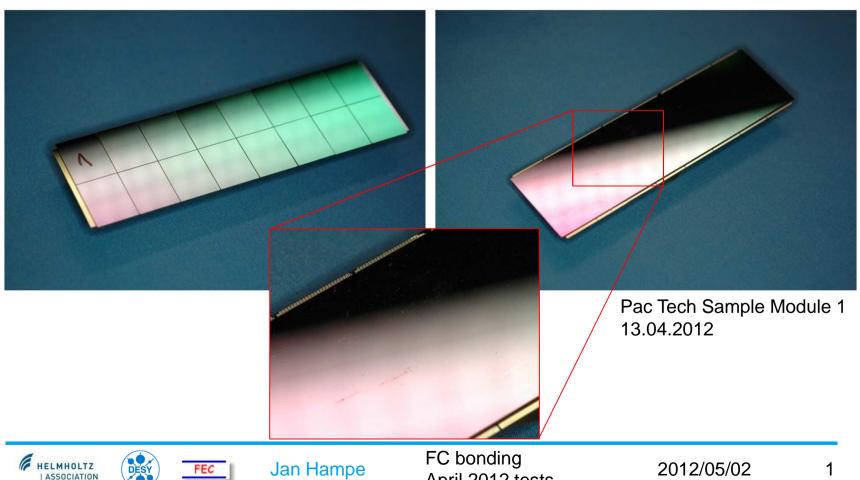
Dummy modules successfully assembled with both machines Femto and LaPlace

TOP AND BOTTOM SIDE PICTURES OF A DUMMY MODULE

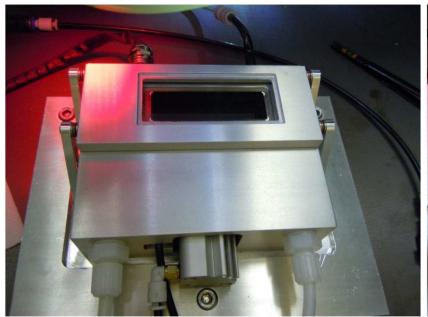






LaPlace formic acid chamber is open during tacking

PICTURES OF A MODULE INSIDE THE FORMIC ACID CHAMBER





Closed during reflow

Open during tacking

- Base plate temperature constantly at 100°C
- 5 N tacking force (2 sec. applied)
- Reflow 10 sec / chip

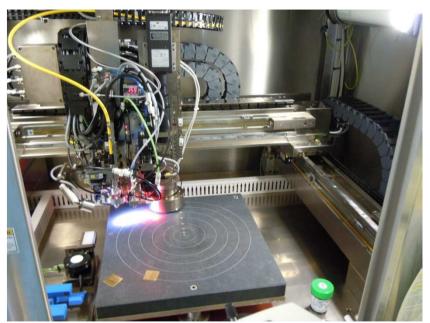


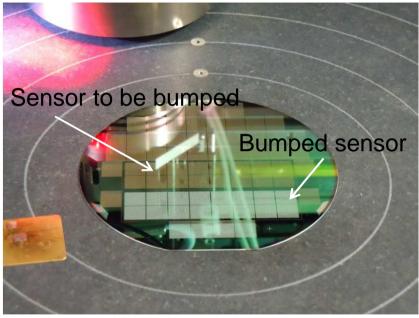




SB² jet process successfully modified to work at high speed also with CMS sensors

SB2 WORKING AREA AND DUMMY WAFER DURING BUMBING





Bumping time

5 bumps / sec (head cleaning procedure every ~1000 bumps)

Jan Hampe

15 min / ROC

240 min / sensor (excl. rework)

2 sensors / day

440 to 500 sensors / year

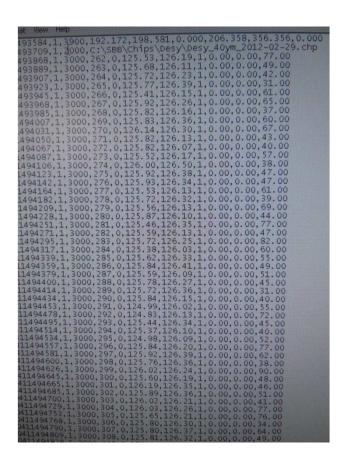






Each bump position is documented and can be accessed directly for rework

PICTURE OF A DUMMY SENSOR ON-SCREEN BUMPING PROCESS LOGFILE



- Real time logging of position and time of each bump
- After sensor completion and inspection each position can be reworked separately







Final version of the Femto formic acid chamber will allow "closed" chamber during tacking

PICTURES OF A MODULE INSIDE THE FORMIC ACID CHAMBER





Closed chamber during reflow

Open chamber

New chamber has an opening in the cover of the size of the bond head that follows the bond head to the next position

Base plate temperature constantly at 100°C

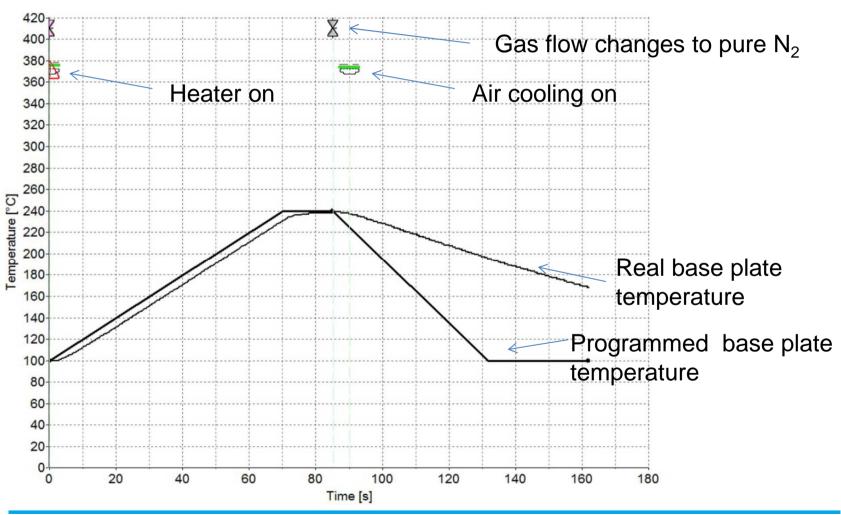
- 5 N tacking force (12 sec. applied)
- Reflow ~170 sec. / sensor





Femto allows complete and easy monitoring of all important parameters

FINAL REFLOW DOCUMENTATION



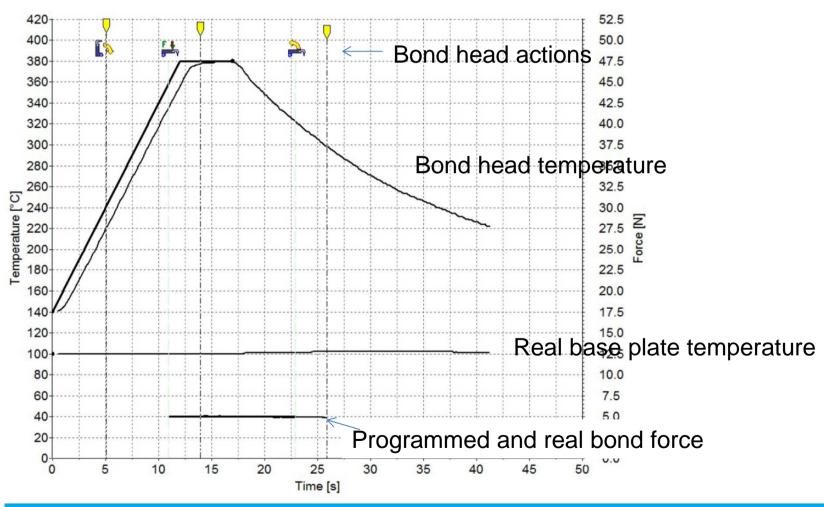






Femto allows complete and easy monitoring of all important parameters

TACKING PROCEDURE DOCUMENTATION





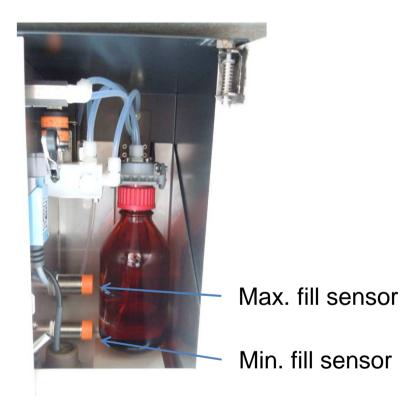


Finetech also delivers a decent and controllable formic acid module

PICTURES OF THE FORMIC ACID MODULE







Inside module

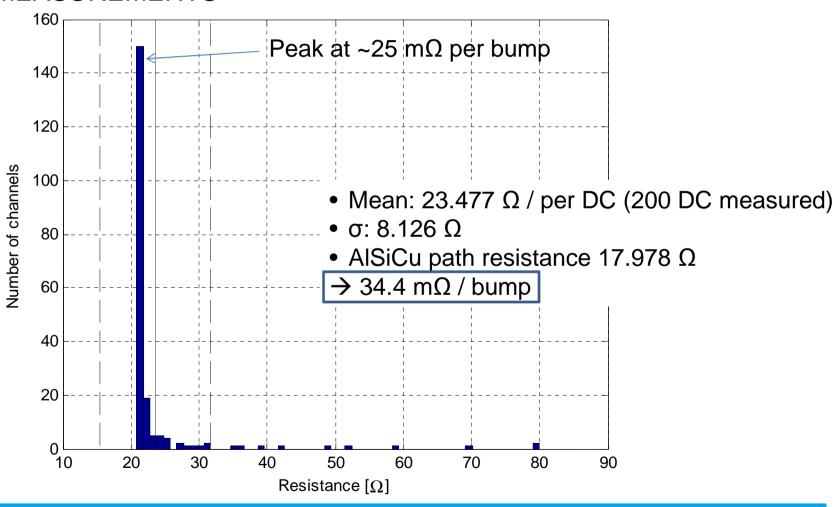






Large variation in resistance measurements found

HISTOGRAMM OF PAC TECH MODUL 2 ELECTRICAL MEASUREMENTS

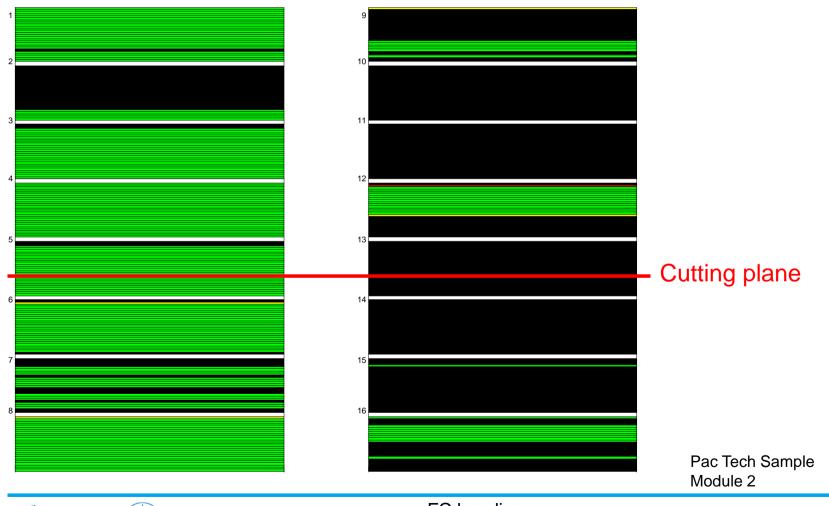






Pac Tech's test bonds have not been reproducible over the module

OPEN PATH DOUBLE COLUMNS IN BLACK







Very compressed bumps can be found for the Pac Tech tacking

CROSS SECTIONS OF PAC TECH MODUL 2 CHIP 5 (CLOSED PATH)



Sensor center



~Sensor center



~ROC center

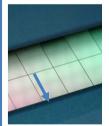


Bump squeezed out

Liquid bumps during tacking?

Pressed too closely

- Different pad sizes on top and bottom of a bump
- > rotational misalignment
- Manual alignment



Going along a column from sensor center outwards.



Different cutting planes presented







Laser energy transfer was higher towards chip center

CROSS SECTIONS OF PAC TECH MODUL 2 CHIP 5 AT TWO DIFFERENT CUTTING PLANES



Close to ROC boundary



Further grinded towards ROC center (~1.5 mm)

IMC growth strongly increased towards chip center

- → Temperature gradient present
- → Input energy distribution is inhomogeneous







Misalignment in theta, level and position lead to open electrical path

CROSS SECTIONS OF PAC TECH MODUL 2 CHIP 13 (OPEN PATH)



Sensor center



~ROC center

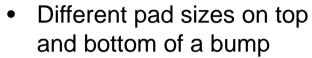


Sensor edge

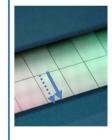


Jan Hampe

Sensor edge



- Strong rotational misalignment
- Different bump heights
- Leveling problem



Going along a column from sensor center outwards.

Different cutting planes presented

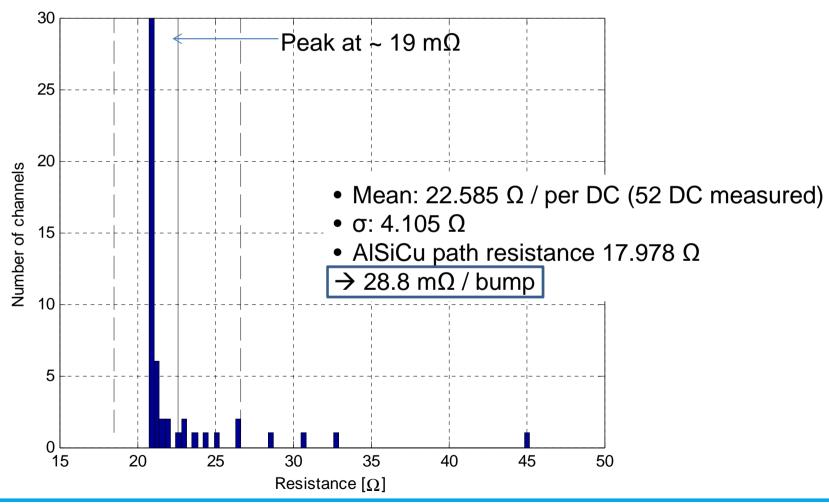






Finetech bonding sample has lower variations in double column resistance

HISTOGRAMM OF FINETECH MODUL 1 ELECTRICAL MEASUREMENTS

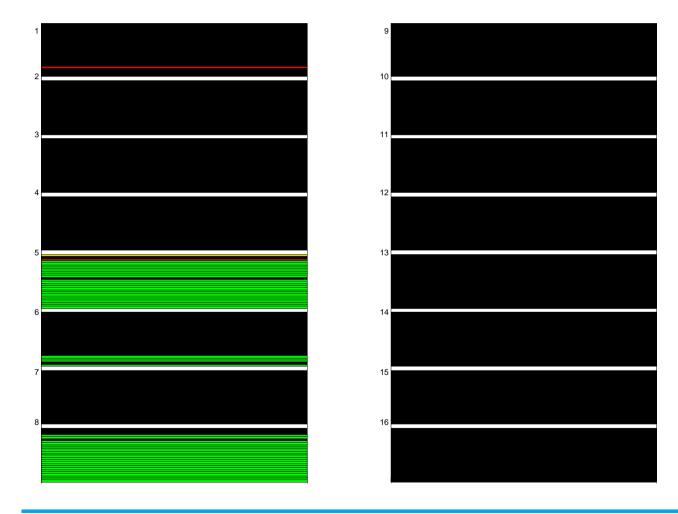






Finetech's test bonds have not been reproducible over the module

OPEN PATH DOUBLE COLUMNS IN BLACK (MODULE 1)







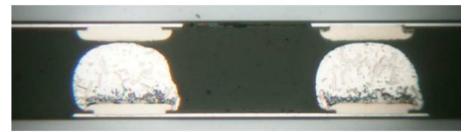


Poor leveling of the bonding tool can be found for the Finetech bond

CROSS SECTIONS OF FINETECH MODUL 2 CHIP 12 (1.5 mm FURTHER GRINDED TO ROC CENTER)



Sensor center



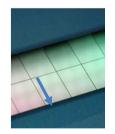
~ROC center



Sensor edge



- Tool was accidentally produced nonflat
- Leveling problem
- Clear IMC growth



Going along a column from sensor center outwards.







An output of about 2 bare modules a working day seems realistic

PROCESS TIMES

Bumping time

5 bumps / sec (head cleaning procedure every ~1000 bumps)

15 min / ROC

240 min / sensor (excl. rework)

2 sensors / day

440 to 500 sensors / year

Limiting time for module production

Bonding time

< 1.5 min / ROC (excl. KGD testing)

< 25 min / Bare Module

Testing time

bumping time – bonding time = enough





